

6th International Conference and Exhibition on **GMP, GCP & Quality Control**

Chicago, USA September 25-26, 2017

Theme: Manufacturing and Quality Guidelines: Its Importance Creates its Need!

Dear Colleagues,

Conference Series LLC is delighted to welcome you to Chicago, USA for the prestigious 6th International Conference and Exhibition on GMP, GCP & Quality Control. GMP Summit 2017 will focus on “*Manufacturing and quality guidelines: Its importance creates its need!*”. We are confident that you will enjoy the Scientific Program of this upcoming Conference.

We look forward to see you at Chicago

With Regards,
GMP Summit 2017 Organizing Committee
Conference Series LLC



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Program Announcement

Venue

Chicago, USA

Important Dates

Abstract submission opens: August 14, 2016

Registration opens: August 14, 2016

Early bird registration: March 31, 2017

On spot registration: September 25, 2017



Accommodation

A large number of rooms have been reserved. Discounted room rates for GMP Summit 2017 participants are proposed. Only reservations made through the Conference will benefit these rates. The Congress Center can be easily reached by public transportation.

Exhibition and Sponsorship

An Exhibition will be held concurrently with the event. The coffee break and lunch areas will be located adjacent to the booths. Thanks to exhibitors from all over the world, attendees will have a complete overview in the field of pharma manufacturing.

About Chicago

Chicago is the third most populous city in both the U.S. state of Illinois and the American Midwest with an average population around 2.7 million. The city lies within the humid continental climate zone and with seasonal variations. Chicago was incorporated as a city in 1837, near a portage between the Great Lakes and the Mississippi River watershed. Today, Chicago is listed as an alpha+ global city by the Globalization and World Cities Research Network, and ranks seventh in the world in the 2012 Global Cities Index. The city is an international hub for finance, commerce, industry, telecommunications, and transportation, with O'Hare International Airport being the second-busiest airport in the world in terms of traffic movements.

In 2012, Chicago hosted 46.2 million international and domestic visitors. Among metropolitan areas, Chicago has the fourth-largest gross domestic product (GDP) in the world, just behind Tokyo, New York City, and Los Angeles, and ranking ahead of London and Paris. Chicago is one of the most important Worldwide Centers of Commerce and trade. Chicago's notability has found expression in numerous forms of popular culture, including novels, plays, films, and songs. The city has many nicknames, which reflect the impressions and opinions about historical and contemporary Chicago. The best-known include "Windy City".

Chicago is famous for its wonderful attractions. On the top of the list is the famous Adler Planetarium, Brookfield zoo, Chicago History Museum, Grant Park, 360 Chicago, Lincoln park zoo. There are a number of outlets and stores located in open malls. Most of these malls are designed to recreate that tropical feel with its architectural designs and structure.

Conference Secretariat

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